

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants : Gabriele Barlocchi et al.  
Application No. : 10/667,113  
Filed : September 18, 2003  
For : METHOD FOR FORMING HORIZONTAL BURIED CHANNELS  
OR CAVITIES IN WAFERS OF MONOCRYSTALLINE  
SEMICONDUCTOR MATERIAL

Examiner : Fazli Erdem  
Art Unit : 2826  
Docket No. : 854063.552D1  
Date : December 21, 2006

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

AMENDMENT

Commissioner for Patents:

In response to the Office Action dated October 23, 2006, please amend the application as follows:

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper.

**Remarks/Arguments** begin on page 6 of this paper.